



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tito Gelsomini

Art Unit: 2812

Serial No.: 10/767,357

Examiner: TBD

Filed: 01/28/04

Docket: TI-36896

For: Method to Overcome Minimum Photomask Dimension Rules

LETTER TO THE OFFICIAL DRAFTSPERSON

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)  
I hereby certify that the above correspondence is being deposited  
with the U.S. Postal Service on 6-22-04 as  
First Class Mail in an envelope addressed to: Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Karen Vertz  
Karen Vertz

6-22-04  
Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed are **THREE (3)** sheets of formal drawings for the above-referenced case.  
Please charge any necessary fees to Deposit Account No. 20-0668 of Texas Instruments  
Incorporated. This sheet is enclosed in triplicate.

Respectfully submitted,

  
Gary C. Honeycutt  
Reg. No. 20,250

Texas Instruments Incorporated  
P.O. Box 655474 M/S 3999  
Dallas, Texas 75265